

## Electron Microscopy Laboratory

### Scale of charges

### Valid from 1.9.2025

Service work at the Laboratory for Electron Microscopy to perform tasks in **research and teaching**.

## Fees for the Institutes of KIT Campus South and Campus North

### A: Device usage fees

For the use of electron microscopy in service operations, flat-rate usage fees are charged in the following amount:

Scanning Electron Microscopy (Instrument Class I, SEM)	Euro 62,-/hour
Scanning electron microscopy incl. high-end analysis (instrument class I, SEM)	Euro 76,-/hour
Focused ion beam, based on TEM (device class II, FIB, TEM)	Euro 121,-/hour
High-end TEM examination (device class III, high-end TEM)	Euro 182,-/hour

### B: Sample preparation

For desired preparation methods, rates are charged in the following amount:

Preparation for SEM/TEM with special requirements: Mechanical and electrolytic thinning incl. grinding and ion thinning, ultramicrotomy, light microscopic quality control, sample vapor deposition	Euro 48,-/hour
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### C: Data preparation

Basic data export is included in the device usage. More extensive evaluation work and data preparation in the form of a report (typ. pdf) are calculated as follows:

Evaluation work and report or presentation preparation	Euro 75,-/hour
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